

Notice of References Cited	Application/Control No. 09/844,040	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Chongshan Chen	Art Unit 2162	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,571,240	05-2003	Ho et al.	707/5
	C	US-6,052,680	04-2000	Towell, Geoffrey Gilmer	706/47
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	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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